



Docket No.: 1592-0178PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Masanori SAKAI et al.

Application No.: 10/549,698

Confirmation No.: 9561

Filed: July 14, 2006

Art Unit: 1709

For: SUBSTRATE PROCESSING APPARATUS
AND PRODUCING METHOD OF
SEMICONDUCTOR DEVICE

Examiner: K. T. Chen

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated June 15, 2007, please amend the above-identified U.S. patent application as follows:

Amendments to the Abstract begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 8 of this paper.